

FORM PTO-3449 (Modified) INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)	Docket No. P0370US-7	Application Number 10/848,937
	Applicant NAKAMURA et al.	
	Filing Date MAY 18, 2004	Group Art Unit 2828

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number							Date	Name	Class	Subclass	Filing Date If Appropriate
KP	4	9	1	2	5	3	2	03/27/90	COOK et al.	357	16	
	5	1	0	3	2	7	1	04/07/92	IZUMIYA et al.	357	17	
	4	9	0	2	3	5	6	02/20/90	NOGUCHI et al.	148	33.4	
	6	8	4	9	8	7	8	02/01/05	BADER et al.	257	103	
	6	7	4	0	6	0	4	05/25/04	KELLY et al.	438	795	
	6	6	0	7	9	3	1	08/19/03	STREUBEL	438	22	
	6	5	5	9	0	7	5	05/06/03	KELLY et al.	438	795	
	6	4	2	0	2	4	2	07/16/02	CHEUNG et al.	438	458	
	6	0	7	1	7	9	5	06/06/00	CHEUNG et al.	438	458	
	5	9	5	8	6	8	7	11/16/99	BOWERS et al.	438	46	
	6	8	0	0	5	0	0	10/05/04	COMAN et al.	438	22	

FOREIGN PATENT DOCUMENTS

	Document Number							Date	Country	Class	Subclass	Translation	
												Yes	No
KP	61	05	9	8	8	6		03/27/86	JAPAN				X
KP	11	23	8	9	1	3		08/31/99	JAPAN				X

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

KP	1	PUBLICATION NO. US2004/0072382 A1, KELLY et al. 04/15/04.
Examiner /Kevin Picardat/		Date Considered 01/04/2007

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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KP ↓	6	4	2	0	1	9	9	07/16/02	COMAN et al.	438	22	
	5	3	7	6	5	8	0	12/27/94	KISH et al.	437	127	
	6	7	5	7	3	1	4	06/29/04	KNEISSL et al.	372	50	
	6	5	6	2	6	4	8	05/13/03	WONG et al.	438	46	
	6	4	4	8	1	0	2	09/10/02	KNEISSL et al.	438	46	
	6	3	6	5	4	2	9	04/02/02	KNEISSL et al.	438	46	
	5	5	0	2	3	1	6	03/26/96	KISH et al.	257	94	
	6	8	0	9	3	4	1	10/26/04	HSU et al.	257	79	
	6	7	1	6	6	5	4	04/06/04	HSU et al.	438	22	
	6	8	4	6	6	8	6	01/25/05	SAEKI et al.	438	22	
	6	4	6	5	8	0	9	10/15/02	FURUKAWA et al.	257	94	

FOREIGN PATENT DOCUMENTS

	Document Number							Date	Country	Class	Subclass	Translation	
												Yes	No


OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

KP	2	PUBLICATION NO. US 2003/0173602, HSU et al., 09/18/2003.
Examiner /Kevin Picardat/		Date Considered 01/04/2007

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Examiner Initial	Document Number							Date	Name	Class	Subclass	Filing Date If Appropriate
KP 	6	3	0	3	4	0	5	10/16/01	YOSHIDA et al.	438	46	
	6	8	0	6	1	1	2	10/19/04	HORNG et al.	438	29	
	6	7	8	6	3	9	0	09/07/04	YANG et al.	228	179.1	
	6	4	6	8	8	2	4	10/22/02	CHEN et al.	438	46	
	6	6	7	7	1	7	3	01/13/04	OTA	438	22	
	6	2	5	8	6	9	9	07/10/01	CHANG et al.	438	458	

FOREIGN PATENT DOCUMENTS

	Document Number							Date	Country	Class	Subclass	Translation	
												Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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FORM PTO 158 (Modified) OFFICE AUG 06 2004 (Use several sheets if necessary)	Docket No. P0370US-7	Application Number 10/848,937
	Applicant NAKAMURA et al.	
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U.S. PATENT DOCUMENTS

Examiner Initial	Document Number							Date	Name	Class	Subclass	Filing Date If Appropriate
KP	6	0	7	1	7	9	5	6/2000	CHEUNG et al.	438	458	
KP	6	4	2	0	2	4	2	7/2002	CHEUNG et al.	438	458	
KP	5	6	7	9	1	5	2	10/1997	TISCHLER et al.	117	97	
KP	6	4	7	5	8	8	9	11/2002	RING	438	571	

FOREIGN PATENT DOCUMENTS

	Document Number							Date	Country	Class	Subclass	Translation	
												Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

KP	1	M.K. KELLY et al., "OPTICAL PROCESS FOR LIFTOFF OF GROUP III-NITRIDE FILMS", RAPID RESEARCH NOTE, TECHNISCHE UNIVERSITÄT MÜNCHEN, GARCHING, GERMANY, (NOV. 28, 1996) pp. 1-2.
KP	2.	E.F. SCHUBERT et al., "RESONANT CAVITY LIGHT-EMITTING DIODE", AT&T BELL LABORATORIES, MURRAY HILL, NEW JERSEY, (1991) pp. 921-923.
KP	3	E.F. SCHUBERT, <u>LIGHT EMITTING DIODES</u> , CAMBRIDGE UNIVERSITY PRESS, (2003) pp. 198-211.
Examiner /Kevin Picardat/		Date Considered 01/04/2007

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FORM PTO-1449 (Modified) INFORMATION DISCLOSURE CTR IN AN APPLICATION (Use several sheets if necessary)	Docket No. P0370US-7		Application Number 10/848,937
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Document (including index, title, date, pertinent pages, etc.)		
KP	1	US 2002/068396 A1 (FITZGERALD, EUGENE, JUNE 6, 2002.
KP	2	US002/0000559 A1 HOOPE, CHRIS VAN et al., JANUARY 3, 2002.

Examiner	/Kevin Picardat/	Date Considered	01/04/2007
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